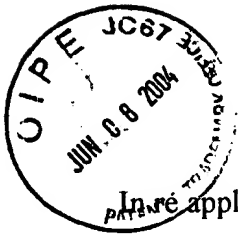


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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

: **Confirmation No. 4689**

Chicara KAWAMURA et al.

: Docket No. 2001-1140A

Serial No. 09/927,328

: Group Art Unit 1714

Filed August 13, 2001

: Examiner K. Wyrozebski Lee

A PROCESS FOR PRODUCING
POLYESTER RESIN

RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 1714

SUPPLEMENTAL AMENDMENT AFTER FINAL REJECTION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please amend the above-identified U.S. patent application as follows:

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975